

TRANSMITTAL OF FORMAL DRAWINGS

Docket No.
14463

In Re Application Of:

Haruo Sunakawa

Serial No.

09/821,411

Filing Date

March 29, 2001

Batch No.

Unassigned

Examiner

Unassigned

Art Unit

Unassigned

Invention: **METHOD OF MANUFACTURING A NITROGEN-BASED SEMICONDUCTOR SUBSTRATE AND A SEMICONDUCTOR ELEMENT BY USING THE SAME**

Address to:

Assistant Commissioner for Patents
Washington, D.C. 20231

Transmitted herewith are:

5 sheets of formal drawing(s) for this application.

Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c) on the reverse side of the drawing.

Dated: May 2, 2001

Signature

Paul J. Esatto, Jr. Registration 30,749

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I certify that this document and attached formal drawings are being deposited on May 2 2001 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Signature of Person Mailing Correspondence

Mishelle Mustafa

Typed or Printed Name of Person Mailing Correspondence